IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT APPLICATION

| Inventors: | Douglas J. Tweet, Sheng Teng Hsu, and Jer-Shen Maa | Attorney Docket No. | |
|--|---|--|--|
| Serial No: | Not Yet Assigned | SLA0586 | |
| Filed: | Herewith | | |
| Title: | METHOD TO FORM LOCAL SILICON-ON-NOTHING OR SILICON-ON-INSULATOR WAFERS WITH TENSILE-STRAINED SILICON | | |
| | DECLARATION FOR PATENT | APPLICATION | |
| address and o original, first a (if plural name patent is sough METHO INSUL | elow named inventor, I hereby declare that citizenship are as stated below next to my reand sole inventor (if one name is listed belowes are listed below), of the subject matter wight on the invention entitled, OD TO FORM LOCAL SILICON-ON-NOTH ATOR WAFERS WITH TENSILE-STRAINE ion of which (check applicable ones): | name; I believe that I am the w), or the first and joint inventor which is claimed and for which a ling OR SILICON-ON- | |
| <u> </u> | is attached hereto; | | |
| _ | was filed with the above-identified "Filed" date and assigned the above-identified "Serial No."; | · | |
| _ | was amended on (or amended through) | · · | |
| I hereby state that I have reviewed and understand the contents of the above- identified specification, including the claims, as amended by any amendment(s) referred to above | | | |

§1.56.

In re Application of:

I acknowledge the duty to disclose information, which is material to the examination of the application in accordance with Title 37, Code of Federal Regulations,

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true, and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

| Full name of sole or first inventor: | Douglas J. Tweet | | |
|--------------------------------------|--|--|--|
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| Post Office Address: | Same | | |
| Citizenship: | USA | | |
| Inventor's signature: Doug Wort | | | |
| Date: March 23, | 2004 | | |
| ******* | ************************************** | | |
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| Date:03 | 8/23/04 | | |

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Inventor's signature:

3-23-04

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PATENT APPLICATION

Inventors:

Douglas J. Tweet, Sheng Teng Hsu,

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METHOD TO FORM LOCAL

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SILICON-ON-INSULATOR WAFERS WITH TENSILE-STRAINED SILICON

Attorney Docket No. SLA0586

POWER OF ATTORNEY BY ASSIGNEE

Sharp Laboratories of America, Inc., a corporation of the State of Washington, Assignee of the entire right, title and interest in and to the above-identified patent application by an assignment document filed herewith, hereby appoints David C. Ripma, Reg. No. 27,672, and Matthew D. Rabdau, Reg. No. 43,026, as its attorneys with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith; said appointment to be to the exclusion of the inventor and the inventor's attorneys in accordance with the provisions of 37 C.F.R. §3.71.

Pursuant to 37 C.F.R. §3.73(b) the undersigned submits herewith the original of an assignment document from the inventor or inventors to Assignee, together with a cover sheet and the fee for recording same. The

undersigned, whose title is supplied below, is authorized to sign this Power of Attorney on behalf of the Assignee.

Please direct all correspondence connected with this application to:

Date: March 23, 2004

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Assignee:

Sharp Laboratories of America, Inc.

y: David C. Ripma

Title: Patent Counsel